

<b>Notice of References Cited</b>	Application/Control No. 10/532,852		Applicant(s)/Patent Under Reexamination MAKI ET AL.	
	Examiner RYAN D. WALSH		Art Unit 2852	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,873,016	02-1999	Kurokawa et al.	399/297
*	B	US-2002/0110392	08-2002	Omata et al.	399/303
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2002060085 A	02-2002	Japan	HAYAKAWA et al.	
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ohata et al., JP 2002193471, July 10, 2002, Machine Translation
	V	Kawaishi et al., JP 05306037, November 19, 1993, Machine Translation
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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